



Docket No.: H6808.0024/P024

(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Hiroshi Miyai et al.

Application No.: 10/669,253

Filed: September 25, 2003

For: AN INSPECTION METHOD AND APPARATUS USING AN ELECTRON

BEAM

Confirmation No.: N/A

Art Unit: N/A

Examiner: Not Yet Assigned

STATUS INQUIRY

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

It is respectfully requested that the attorney named below be advised of the status of the above-identified application. Please advise us of when we might expect to receive a Filing Receipt from the Patent and Trademark Office.

Dated: June 23, 2004

Respectfully submitted,

Mark J. Thronson

Registration No.: 33,082

Gabriela I. Coman

Registration No.: 50,515

DICKSTEIN SHAPIRO MORIN &

Galoriele Coma

OSHINSKY LLP

2101 L Street NW

Washington, DC 20037-1526

(202) 785-9700

Attorneys for Applicant